RECC

03-09-2001

HEET

Docket No. 00674/HG

D. 26.01

101630982

To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

Masanori MAYUSUMI Masato IMAI Kazutoshi INOUE Shinji NAKAHARA

2. Name and address of receiving party(ies):

SUPER SILICON CRYSTAL RESEARCH INSTITUTE CORP. 555-1, Nakanoya, Annaka-shi Gumma, 379-0125 Japan

Execution Date(s): October 26, 2000 , October 2	26, 2000 , October 26, 2000 ,
5.4. 40.0004	
February 19, 2001 ,	,, respectively.
4. Application number(s) or patent number(s):	
If this document is being filed together with a new applicati	on, the execution date of the application is as follows:
708/2001 DEYRNE 00000296 09646718	,, respectively
FC:581 40:09 0P	
A. Patent Application No. (s	B. Patent No.(s)
09/646,718	
5. Name and address of party to whom correspondence con-	cerning document should be mailed:
5. Name and address of party to whom consequent	
FRISHAUF, HOLTZ, GOODMAN, LANGE 767 Third Avenue, 25th Floor New York, New York 10017-2023	ER & CHICK, P.C.
6. Total number of applications and patents involved:1	7. Total fee (37 CFR 3.41): \$ 40.00
	[] Amount included with filing fee attached hereto.
	[X] Check enclosed.
	N 05 1278
8. To the extent not tendered by check, authorization is given to c	harge the Assignment Fee (37 CFR.341) to Account No. 06-1376.
9. Statement and signature:	decrees and any attached copy is a true copy of the
To the best of my knowledge and belief, the foregoing inf original document.	ormation is true and correct and any attached copy is a true copy of the
Original documents	the Marketin
Dated: February 21, 2001	By: Herbert Goodman Reg. No. 17,081
CERTIFICATE OF MAILING	Destal Service with sufficient postage as First Class mail in a
I hereby certify this correspondence is being deposited with the Un envelope addressed to: Commissioner of Patents and Trademarks	nited States Postal Service with sufficient postage as First Class mail in a , Washington, D.C. 20231 on the date noted below.
I La Jone to	
// // // / Oaa A.	Dated: February 21, 2001

5/95

Total number of pages including cover sheet, attachments and document: 3

PATENT REEL: 011556 FRAME: 0064

ASSIGNMENT

In consideration of value received, I, having a residence and post office address as stated below next to my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural names are listed below) of an invention described in an application for United States patent entitled:

"METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER"

sell and assign to SUPER SILICON CRYSTAL RESEARCH INSTITUTE CORP.

a corporation of Japan

having a business address at 555-1, Nakanoya, Annaka-shi, Gumma, 379-0125 Japan

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said application for United States patent SN 09/646,718 deposited September 21, 2000;

and in and to all applications for patent and patents for said invention, in all countries of the world, including all divisions, reissues, continuations, substitutions and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty it is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention in all countries.

I hereby grant to any attorney member of the following law firm the power to insert on this Assignment the Serial Number and filing date of said application when known.

SERIAL NO .:

FILING DATE:

Frishauf, Holtz, Goodman, Langer & Chick, P.C., 767 Third Avenue - 25th Floor, New York, N.Y. 10017-2023.

INVENTOR: SIGNATURE	DATE	ADDRESS
Sign: Yasanori Mayusumi	Date: 26 / 10 / 2000	Address: 12-37, lsobe 3-chome, Annaka-shi Gumma, 379-0127 Japan
Type: Masanori MAYUSUMI	Witness:	
Sign:	Date: 26/10/2000	Address: Casa Verde II-204, 22-55, Annaka 3-chome Annaka-shi, Gumma, 379-0116 Japan
Type: Masato IMAI	Witness:	
Sign: Inoue, Kazutoshi	Date: 26/10/2000	Address: Bunkyo Heights 203 36-18, Bunkyo-cho 1-chome, Maebashi-shi Gumma, 371-0801 Japan
Type: Kazutoshi INOUE	Witness:	

NOTES: MUST BE DATED.

WITNESS DESIRABLE.

LEGALIZATION NOT REQUIRED.

RECORDING OFFICER:

After recording, please return to:

FRISHAUF, HOLTZ, GOODMAN, LANGER & CHICK, P.C. 767 Third Avenue - 25th Floor, New York, N.Y. 10017-2023 Tel. No.: (212) 319-4900 Fax No.: (212) 319-5101

PATENT REEL: 011556 FRAME: 0065

RECORDED: 02/26/2001

ASSIGNMENT

INVENTOR:SIGNATURE	DATE	ADDRESS
Shinji Nakahara	Date: Feb. 19, 2001	Address: 1412-2,lizuka-machi, Takasaki-shi Gumma, 370-0069 Japan
Type: Shinji NAKAHARA	Witness	
Sign:	Date:	Address:
Type:	Witness:	
Sign:	Date:	Address:
Type:	Witness:	
Sign:	Date:	Address:
Type:	Witness:	
Sign:	Date:	Address:
Type:	Witness:	
Sign:	Date:	Address:
Туре:	Witness:	
Sign:	Date:	Address:
Туре:	Witness:	
Sign:	Date:	Address:
Туре:	Witness:	

PATENT REEL: 011556 FRAME: 0066